

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yukihiro Morita et al.

Serial No.: 10/533,605

Filed: April 29, 2005

For: PLASMA DISPLAY PANEL AND
MANUFACTURING METHOD FOR THE
SAME

Patent Examiner: Raabe, Christopher M.

Group Art Unit: 2879

Confirmation No. 4549

October 17, 2007

Costa Mesa, California 92626

**SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following references, which were found during the prosecution of a co-pending European patent application:

US Patent No. 5,454,861
US Publication No. 2001/0026129
European Publication No. 1 033 740 A1
Japanese Publication No. 1-238462 with English Abstract
Japanese Publication No. 1-186738 with English Abstract
Japanese Publication No. 2002-124180 with English Abstract

A copy of the foreign references and form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in

a counterpart foreign application not more than three months prior to the filing the information disclosure statement.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

SNELL & WILMER LLP



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INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)			Docket Number (Optional) 92478-2600		Application Number 10/533,605		
			Applicant(s) Yukihiro Morita et al.				
			Filing Date April 29, 2005		Group Art Unit 2879		
			U. S. PATENT DOCUMENTS				
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,454,861	10.3.1995	Hasegawa et al.			
U. S. PATENT APPLICATION PUBLICATIONS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2001/0026129	10.4.2001	Ahn et al.			
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	1 033 740 A1	9.6.2000	Europe			X	
	1-238462	9.22.1989	Japan w/English Abstract			X	
	1-186738	7.26.1989	Japan w/English Abstract			X	
	2002-124180	4.26.2002	Japan w/English Abstract			X	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER			DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							